Atty. Dkt. No. 039262-0144



THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:

Tadahiro OHMI et al.

Title:

METHOD OF CLEANING SUBSTRATE PROCESSING

**APPARATUS** 

Appl. No.:

10/555,668

Filing Date:

12/21/2005

Examiner:

Nicole R. Blan

Art Unit:

1792

Confirmation No.:

9889

## **AMENDMENT AND REPLY UNDER 37 C.F.R. 1.116**

Mail Stop **BOX AF** Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

This communication is responsive to the Final Office Action dated June 10, 2008, concerning the above-referenced patent application.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this document.

Remarks/Arguments begin on page 5 of this document.

Please amend the application as follows: